



Stand Alone SMENA
(scanning-by-probe system configuration)

The Stand Alone SMENA expands the scope of scanning probe microscopy to bring you innovative facilities for investigating samples of unlimited size in all available SPM measuring modes. In spite of such versatile measuring capabilities, SMENA has a very compact low weight design and a reasonable price.

There is a configuration of SMENA with closed liquid cell with a flow of liquid. For more information please take a look at <http://www.ntmdt.com/device/smena>

Measuring Modes

In air: STM/ STS/ Contact AFM/ LFM/ ResonantMode (semicontact AFM+noncontact AFM)/ Phase Imaging/ Force Modulation (viscoelasticity)/ Spreading Resistance Imaging/ MFM/ EFM/ SCM/ SKM/ Adhesion Force Imaging/ Shear Force/ AFM (Force + Voltage), STM, RM Lithographies
In liquid: Contact AFM/ LFM/ ResonantMode AFM (semicontact)/ Phase Imaging/ Force Modulation (viscoelasticity)/ Adhesion Force Microscopy/ AFM (Force) Lithography

Applications

- Polymers
- Biology and Medicine
- Semiconductors
- Material Science
- Optical and Magnetic Storage
- Coating and Polishing Quality Control
- Large Optics, etc.

Technical Specification

Sample Size	Unlimited Note: Small samples (up to Ø100 mm) can be placed between the SMENA head legs Closed liquid cell limits sample size up to 22x22x2 mm
Scanners	50x50x2.5 µm (±10%); 100x100x3.5 µm (±10%) 12x12x1.5 µm (±10%) (for STM only) 80x80x3.5 µm (±10%) (for Shear Force only)
Min. Scanning Step	0.006 nm; 0.01 nm; 0.0015 nm; 0.009 nm
Scanning Type	by probe
Control System	SPM Controller (see "SPM Controller", page 25)
Vibration Isolation	Active anti-vibration system is available by request (see "Vibration isolation solutions", page 34)

MEASURING HEADS FOR SMENA

SFC050

Universal SPM scanning head SMENA for basic AFM modes in air. Scanner: $50 \times 50 \times 2.5 \mu\text{m}$ ($\pm 10\%$). Cantilever tracking system, tip-to-sample manual approach system.

SFC050SEMI

Universal SPM scanning head SMENA. Modification of SFC050 for operation in additional modes: SCM, SKM, Spreading Resistance and Voltage Lithography. Scanner: $50 \times 50 \times 2.5 \mu\text{m}$ ($\pm 10\%$). Cantilever tracking system, tip-to-sample manual approach system.



SFC050, SFC050SEMI

SFC090

Universal SPM scanning head SMENA for basic AFM modes in air. Scanner: $100 \times 100 \times 3.5 \mu\text{m}$ ($\pm 10\%$). Cantilever tracking system, tip-to-sample manual approach system.

SFC090SEMI

Universal SPM scanning head SMENA. Modification of SFC090 for operation in additional modes: SCM, SKM, Spreading Resistance and Voltage Lithography. Scanner: $100 \times 100 \times 3.5 \mu\text{m}$ ($\pm 10\%$). Cantilever tracking system, preamplifiers, tip-to-sample manual approach system.



SFC090, SFC090SEMI

SFC050L

Universal SPM scanning head SMENA. Modification of SFC050 for operation in basic AFM modes in liquid. Scanner: $50 \times 50 \times 2.5 \mu\text{m}$ ($\pm 10\%$). Cantilever tracking system, tip-to-sample manual approach system. Replaceable cantilever holder for operation in air.

SFC090L

Universal SPM scanning head SMENA. Modification of SFC090 for operation in basic AFM modes in liquid. Scanner: $100 \times 100 \times 3.5 \mu\text{m}$ ($\pm 10\%$). Cantilever tracking system, tip-to-sample manual approach system. Replaceable cantilever holder for operation in air.



SFC090L



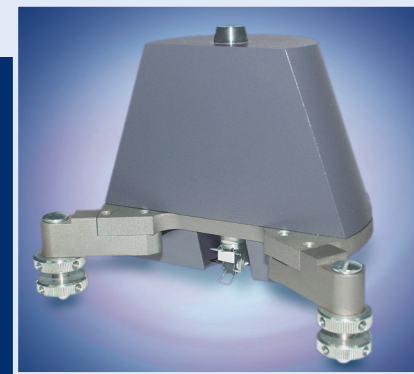
SFS012

SFS012

STM scanning head with preamplifier (30pA-50nA). Scanner: $12 \times 12 \times 1.5 \mu\text{m}$ ($\pm 10\%$).

SNC080

Shear Force (SNOM) scanning head with quartz detector of fiber vibration (without SNOM illumination and detection system). Scanner: $80 \times 80 \times 3.5 \mu\text{m}$ ($\pm 10\%$).



SNC080



SMENA head with positioning stage and DBM03

DBM03



DBM03

Antivibration suspension for SMENA heads on MP1SM.



SMENA head on MP0LS

MP0LS



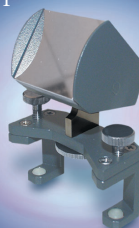
MP0LS

SMENA base for large samples. Scanning point position can be located up to 150 mm from the sample edge.



SMENA head with positioning stage and MA001

MA001



MA001

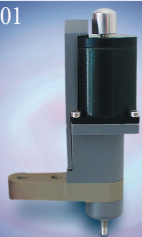
Adjustable mirror for optical viewing for SMENA heads on MP1SM and MP1LC.

PARTS FOR SMENA

LGM01

Motorized approach leg for SMENA, SFS012 and SNC080 heads.

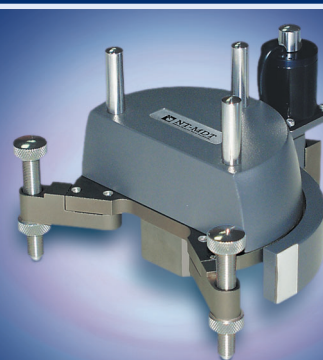
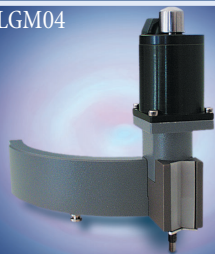
LGM01



LGM04

Motorized approach leg for SMENA, SFS012 and SNC080 heads on XY scanning stages with manual positioning (SCTPON, SCTPZN, SCTPO, SCTPZ).

LGM04



STM SMENA with installed LGM04

AA010

Attachment for atomic resolution measurements. For SFS012 STM head on MP1SM, SCB01A.

STM SMENA head with positioning stage and AA010

Insert part for AA010



AA110

Attachment for atomic resolution measurements. For SMENA heads SFC050, SFC050SEMI, SFC090, SFC090SEMI on MP1SM, SCB01A.

Insert part for AA110 (for stand alone use)



Insert part for AA110 (to be used with positioning stage)



Stand Alone SMENA head with installed AA110

AA020

Attachment for atomic resolution measurements. For SFS012 STM head on XY scanning stage with manual positioning (SCTPON, SCTPZN, SCTPO, SCTPZ).

Bottom part of the liquid cell



MP1LC

Manual X, Y positioning stage with closed liquid cell with flow. For biological applications. Range of sample positioning 1x1 mm, positioning resolution 5 μ m. For SMENA.

For more information please take a look at <http://www.ntmdt.com/products/SMENA.3.html>



SMENA head with MP1LC